

The EKV Model Parameter Extraction Based on its IC-CAP USERC Implementation

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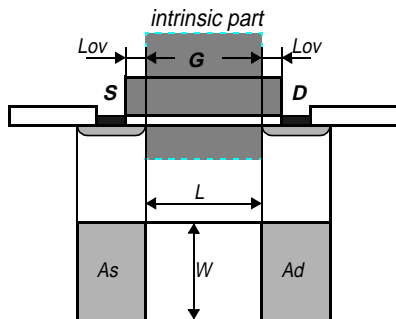
- The EKV v2.6 Model
- Userc Implementation in IC-CAP
- Parameter Extraction Methodology
 - ✓DC sequence
 - ✓CV modeling example
- Summary

EKV v2.6 MOSFET Model

- EKV v2.6 in summary:
 - ✓a **physics based** MOST model in the **public domain**.
 - ✓dedicated to **analog circuit simulation** for submicron CMOS.
 - ✓has < 20 intrinsic model parameters.
 - ✓used in industrial and academic design groups.
- EKV v2.6 available in major commercial circuit simulators:
 - ✓Antrim-AMS, APlac, Eldo-Accusim, PSpice, Saber, SmartSpice, Smash, Spectre, Star-HSpice
 - ✓on-going implementations:
 - ADS (at LEG-EPFL), MacSpice, Spice3, T-Spice
 - MINIMOS (TU Vienna), TRANZ-TRAN (TU Budapest)
- **New:** EKV model web site: <<http://legwww.epfl.ch/ekv>>

Intrinsic MOST and Extrinsic Parasitic Elements

Structure of the MOST

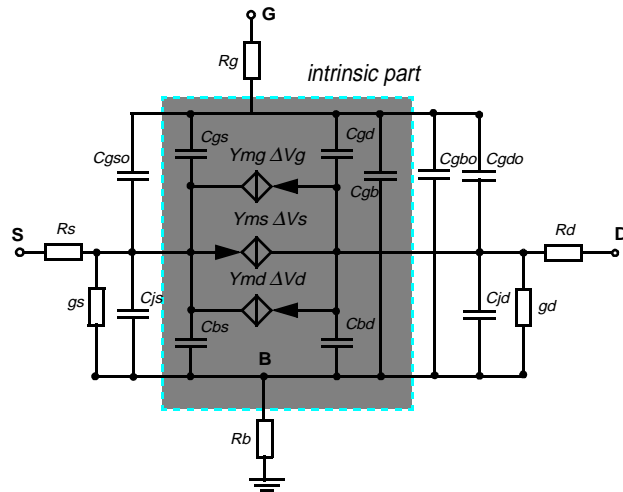


$$C_{js(d)} = A_{s(d)} * C_j + P_{s(d)} * C_{jsw}$$

$$C_{ov} = W * L_{ov} * C_{ox}$$

P_s, P_d - perimeter
 A_s, A_d - area

Corresponding small-signal EKV model



EKV v2.6 Modeled Effects

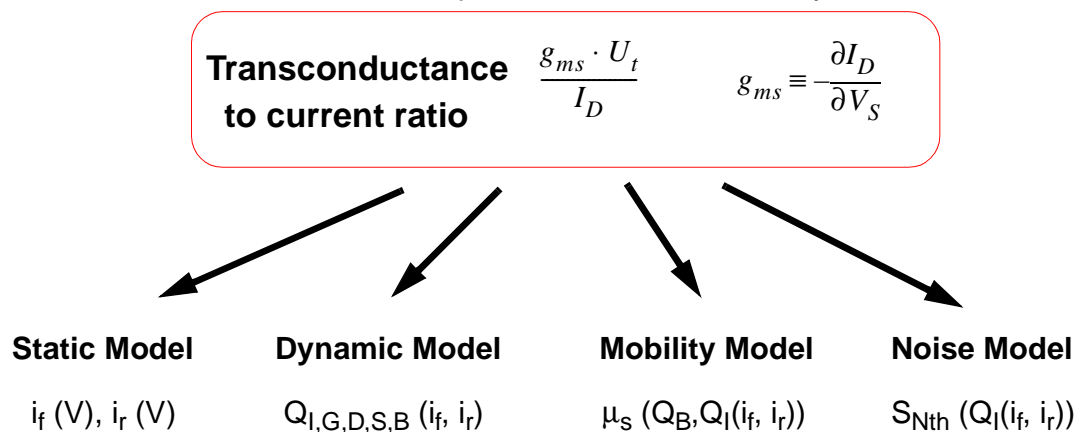
- ❑ Physics-based modeling of weak, moderate and strong inversion.
- ❑ Effects of substrate doping level, substrate effect.
- ❑ Vertical field dependent mobility.
- ❑ Common short-channel effects:
 - ✓ velocity saturation
 - ✓ channel length modulation (CLM)
 - ✓ two-dimensional bulk charge-sharing for short-and narrow-channel effects
 - ✓ reverse short-channel effect (RSCE)
 - ✓ substrate current effects on drain conductance
- ❑ Short-distance matching for statistical circuit simulation.

EKV v2.6 Model Structure

- Coherent model for static, dynamic and noise aspects.

✓ physical model basis leads to accurate description of transconductance-to-current ratio at all current levels

✓ allows to derive all other model quantities in a coherent way



✓ common variable to the entire model:
normalized currents i_f and i_r (forward and reverse)

EKV v2.6 Parameter Set

- 18 Intrinsic Model Parameters

Purpose	NAME	DESCRIPTION	UNITS	EXAMPLE
Process parameters	COX	gate oxide capacitance per unit area	F/m^2	$3.45E-3$
	XJ	junction depth	m	$0.15E-6$
	DW	channel width correction	m	$-0.05E-6$
	DL	channel length correction	m	$-0.1E-6$
Doping & Mobility related parameters	VTO	long-channel threshold voltage	V	0.55
	GAMMA	body effect parameter	\sqrt{V}	0.7
	PHI	bulk Fermi potential (*2)	V	0.8
	KP	transconductance parameter	A/V^2	$160E-6$
	E0	vertical characteristic field for mobility reduction	V/m	$80E6$
	UCRIT	longitudinal critical field	V/m	$4.0E6$
Short- & narrow-channel effect parameters	LAMBDA	depletion length coefficient (channel length modulation)	-	0.3
	WETA	narrow-channel effect coefficient	-	0.1
	LETA	short-channel effect coefficient	-	0.3
	Q0	reverse short-channel effect peak charge density	$A \cdot s/m^2$	$500E-6$
	LK	reverse short-channel effect characteristic length	m	$0.34E-6$
Substrate current related parameters	IBA	first impact ionization coefficient	$1/m$	$260E6$
	IBB	second impact ionization coefficient	V/m	$350E6$
	IBN	saturation voltage factor for impact ionization	-	1.0

EKV v2.6 Parameter Set (cont.)

□ Completed with 3 matching parameters

NAME	DESCRIPTION	UNITS	Example
AVTO	area related threshold voltage mismatch parameter	V_m	- $DEV=15E-9$
AKP	area related gain mismatch parameter	m	- $DEV=25E-9$
AGAMMA	area related body effect mismatch parameter	$\sqrt{V_m}$	- $DEV=10E-9$

□ 4 temperature parameters

NAME	DESCRIPTION	UNITS	Example
TCV	threshold voltage temperature coefficient	V/K	$1.0E-3$
BEX	mobility temperature exponent	-	-1.5
UCEX	longitudinal critical field temperature exponent	-	0.8
IBBT	temperature coefficient for IBB	$1/K$	$9.0E-4$

□ 2 noise parameters

NAME	DESCRIPTION	UNITS	Example
KF	flicker noise coefficient	-	0
AF	flicker noise exponent	-	1

EKV v2.6 Model and Userc Function

□ Userc implementation of the EKV v2.6 model

✓ *simulator independent*

✓ *direct link to IC-CAP; very fast execution time*

✓ *open environment for model evaluation and verification*

□ EKV v2.6 userc function

✓ *Inputs:*

terminal voltages (V_d, V_s, V_b, V_g)

✓ *Outputs:*

all currents (I_d, I_s, I_b, I_g),

conductances,

capacitances (C_{gg}, C_{gd}, C_{gb}),

charges.

EKV v2.6 Model and Userc Function (cont.)

□ Adding EKV v2.6 model to the function list

```
add_double_c_func2("EKV_dc_model", ekv26_dc_mod, 4, -1, 0, 1, FUNC_MAN, 0);
add_input_name("VD");
add_input_name("VG");
add_input_name("VS");
add_input_name("VB");
add_parameter_name("Output");
```

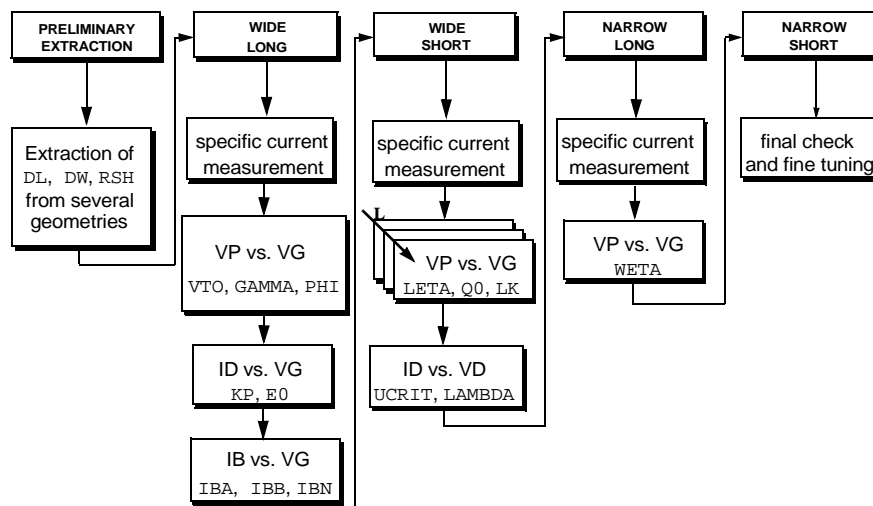
□ Defining EKV v2.6 function

```
static int ekv26_dc_mod ( USERC_DECLS1 ) USERC_DECLS2
```

□ IC-CAP user interface:



EKV v2.6 DC Parameter Extraction Methodology



□ Sequential task: parameter extraction methodology established for EKV v2.6

✓ performed from an array of transistors in the W/L plane.

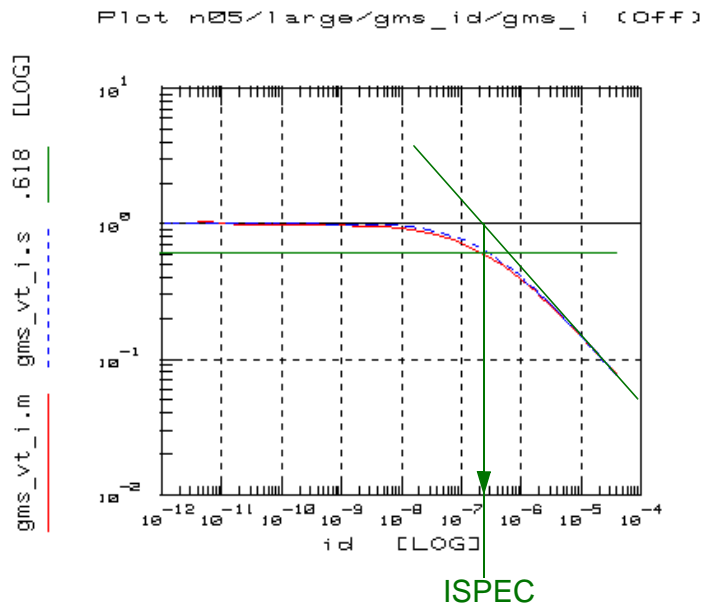
EKV v2.6 Specific Current Extraction

Transconductance-to-current ratio in saturation:

$$\frac{g_{ms} \cdot U_t}{I_D} = \frac{1}{\sqrt{\frac{1}{4} + \frac{I_D}{I_S} + \frac{1}{2}}}$$

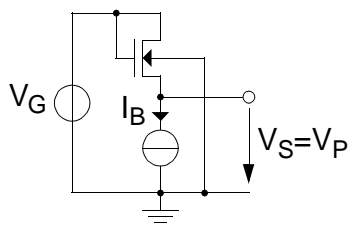
setting I_D/I_S to 1:

$$\frac{1}{\sqrt{\frac{1}{4} + 1 + \frac{1}{2}}} = 0.618$$



- ✓ Specific current I_S corresponds to intersection of strong & weak inversion asymptotes [5];
- not affected by: CLM, high field mobility reduction, S/D extrinsic resistances

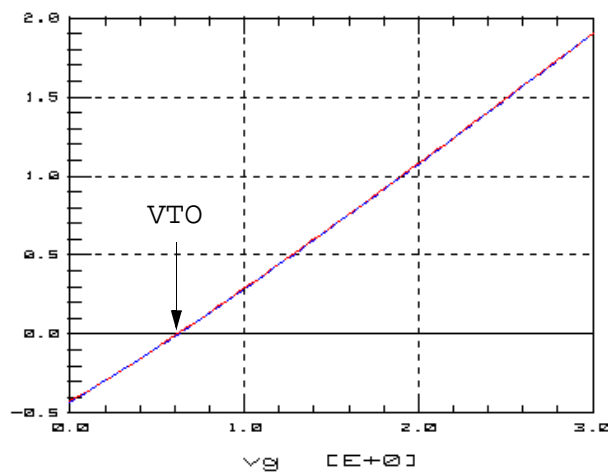
Pinch-off Voltage Characteristic



$$I_B \cong \frac{I_S}{2} = n \cdot \beta \cdot U_T^2$$

vs.m vs.s [E+0]

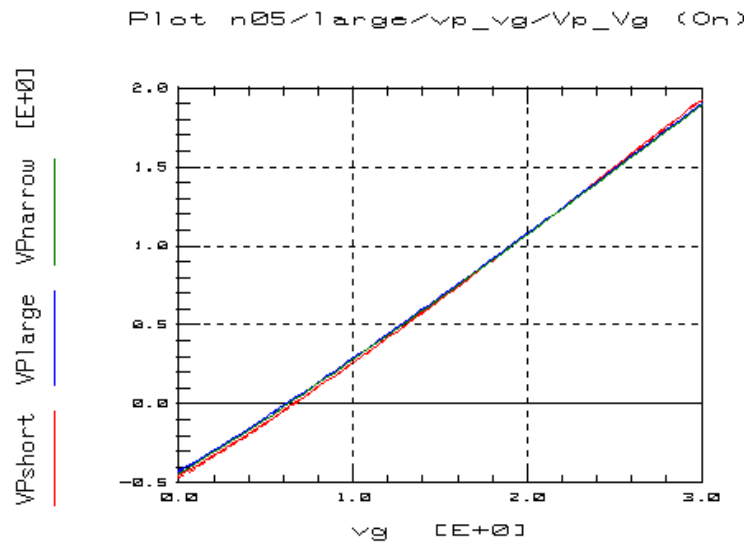
Plot n05/large/vp_vg/vp_vg (On)



- Pinch-off voltage measurement at constant current ($I_S/2$)

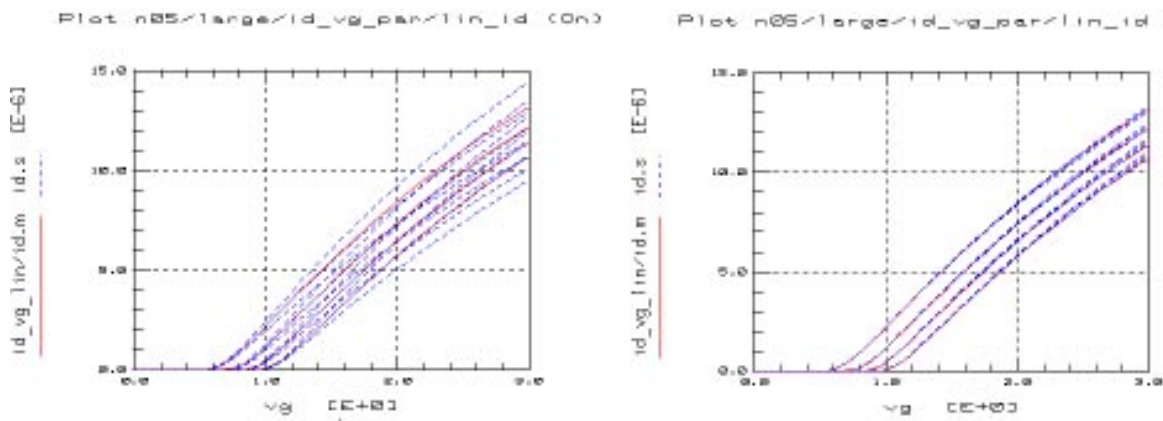
- ✓ Gate voltage V_G is swept and $V_P=V_S$ is measured at the source for a transistor biased in moderate inversion and saturation [1,7]

Short- and Narrow-Channel Effects on V_p - V_g



- ❑ Effects of short- and narrow-channels are analysed using the charge-sharing approach.
- ❑ Corresponding parameters: $L\eta_A$ and $W\eta_A$.

Mobility Model

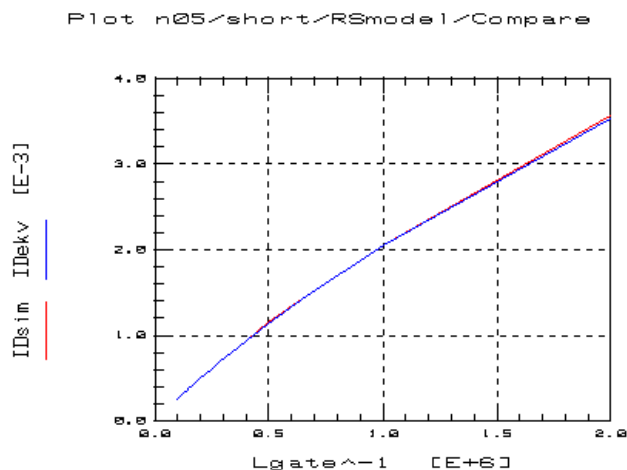


Influence of K_P and E_0 on the transfer characteristics, respectively

- ❑ Good behaviour for mobility reduction for both channel types.
- ❑ Substrate effect is correctly accounted for.
- ❑ No back-bias dependence required.

Source/Drain Resistances

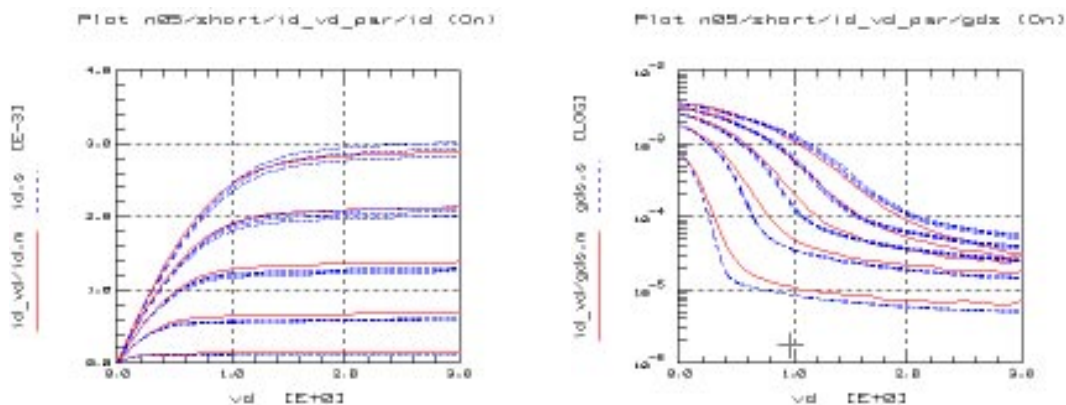
$$\frac{I_D}{I_{D0}} = \frac{g_m}{g_{m0}} = \frac{g_{ms}}{g_{ms0}} = \frac{g_d}{g_{d0}} \cong \frac{1}{1 + g_{ms0}R_S + g_{d0}R_D}$$



Drain current vs. gate length

- Series resistance accounted explicitly in drain current
 - ✓ No extra nodes needed
 - ✓ Increased computation efficiency
 - ✓ S. Cserveny, *IEEE Trans. Electron Devices*, ED-37, no.11, 1990, pp.2413-2414.

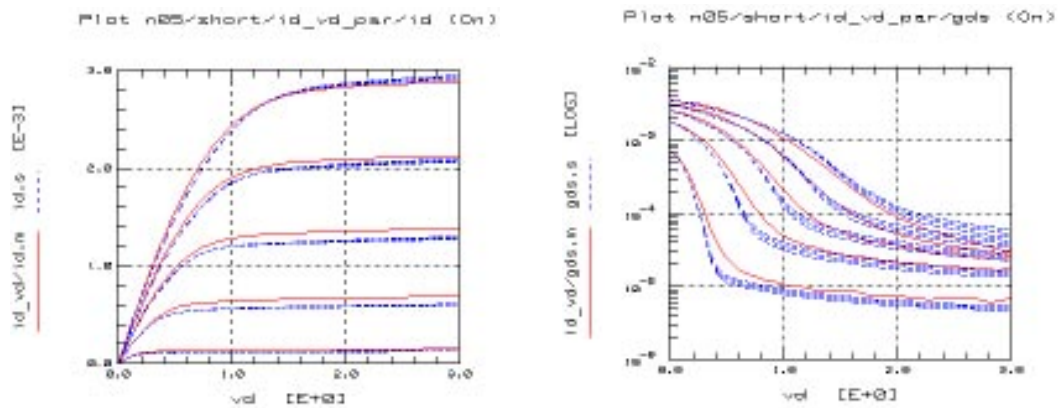
Velocity Saturation



Influence of UCRIT on the output characteristics

- A high lateral electric field in the channel causes the carrier velocity to saturate and limits the drain current.
- Parameter UCRIT accounts for this effect.

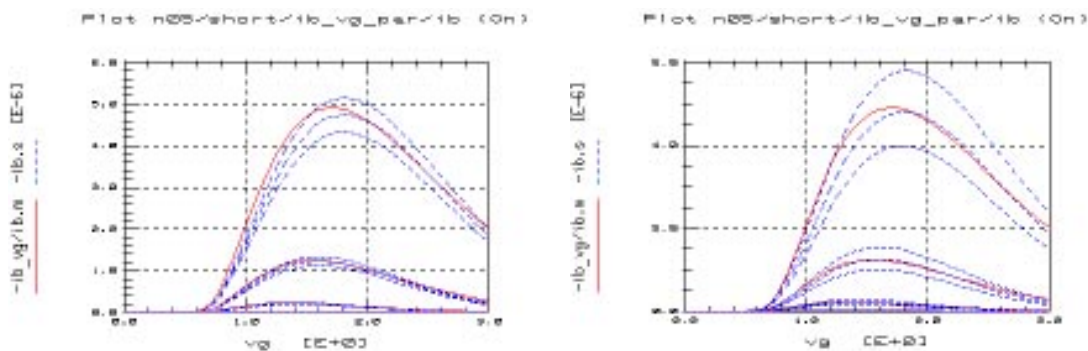
Channel-Length Modulation (CLM)



Influence of LAMBDA on the output characteristics

- The relative channel length reduction depends on the pinch-off point in the MOSFET channel near drain end.
- Depletion length coefficient (LAMBDA) models CLM effect.

Impact Ionization Current



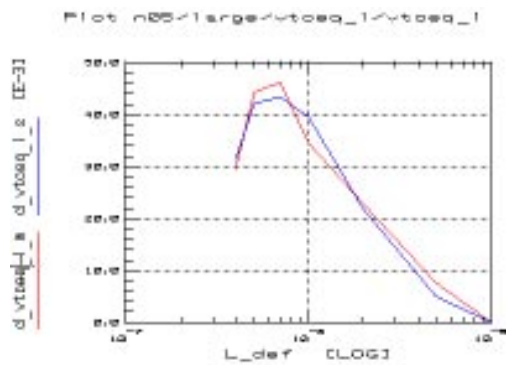
Influence of IBA and IBB on the substrate current, respectively

- The substrate current is treated as a component of the total extrinsic current:

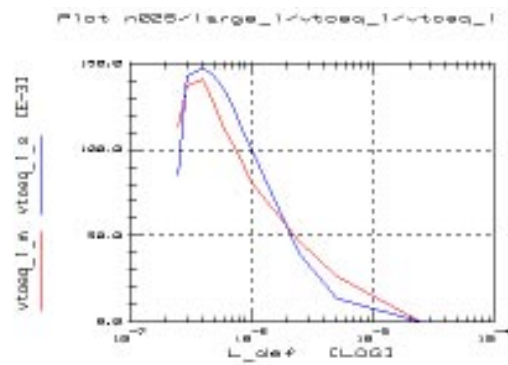
$$\checkmark I_D = I_{DS} + I_{DB}$$

- Substrate current affects the total extrinsic conductances, in particular drain conductance (g_{DS}).

Reverse Short Channel Effect (RSCE)



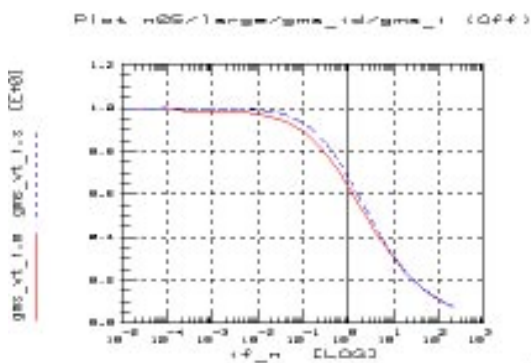
0.5um CMOS example



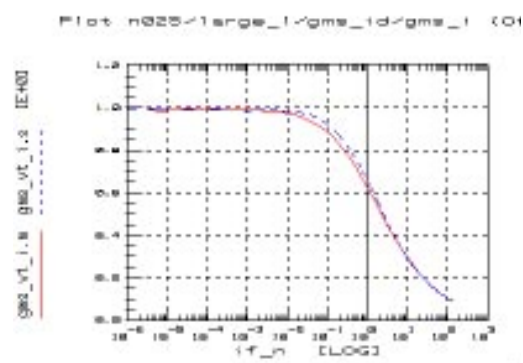
0.25um CMOS example

- ❑ Defect enhanced diffusion during fabrication leads to RSCE.
- ❑ RSCE is modeled as a change in the threshold voltage depending on L_{eff}
- ❑ Two model parameters Q_0 and L_K .

Transconductance to Current Ratio



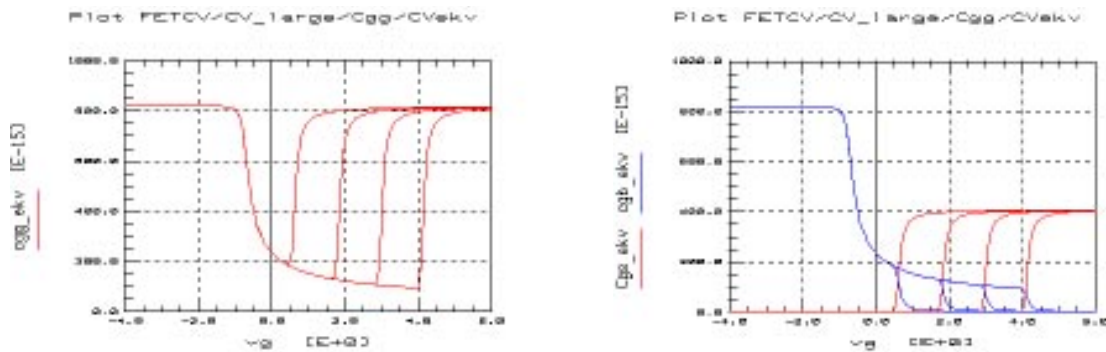
0.5um CMOS example



0.25um CMOS example

- ❑ Excellent match from weak through moderate to strong inversion regions.
- ❑ Measurement and simulation comparisons show that $g_{\text{ms}}/i_{\text{D}}$ ratio is technology independent.

CV Modeling Example



CV characteristics (C_{gg} , C_{gs} , C_{gb}) of large MOSFET
as function of channel to bulk bias ($V_S = V_D$)

- Consistent model for all charges and capacitances (G,D,S,B).
- Capacitances are valid in all operating regions, continuous, and symmetrical at $V_{DS}=0$

Summary

- The EKV v2.6 model and related parameter extraction methodology have been developed at Electronics Lab of EPFL.
- Complete DC and CV EKV v2.6 model has been implemented as the IC-CAP userc function and offers:
 - ✓very fast execution time
 - ✓perfect model development/verification environment
 - ✓well suited for mixed mode (direct and optimization based) extraction as well as for statistical modeling tasks
- Presented examples showed the EKV v2.6 model applications down to deep submicron technologies.

Parameter Extraction Service

- ❑ Parameter extraction service and design support are available through Smart Silicon Systems, Lausanne
- ❑ The EKV v2.6 parameter extraction kit for IC-CAP is under development
 - ✓ *modular structure:*
 - ✧ *measurement unit with mdm data base generator*
 - ✧ *general EKV v2.6 model extractor*
- ❑ Additional activities:
 - ✓ *RF modeling including S-parameter characterization*
 - ✓ *1/f noise characterization*
- ❑ Contact: modeling@smartsilicon.ch

References

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